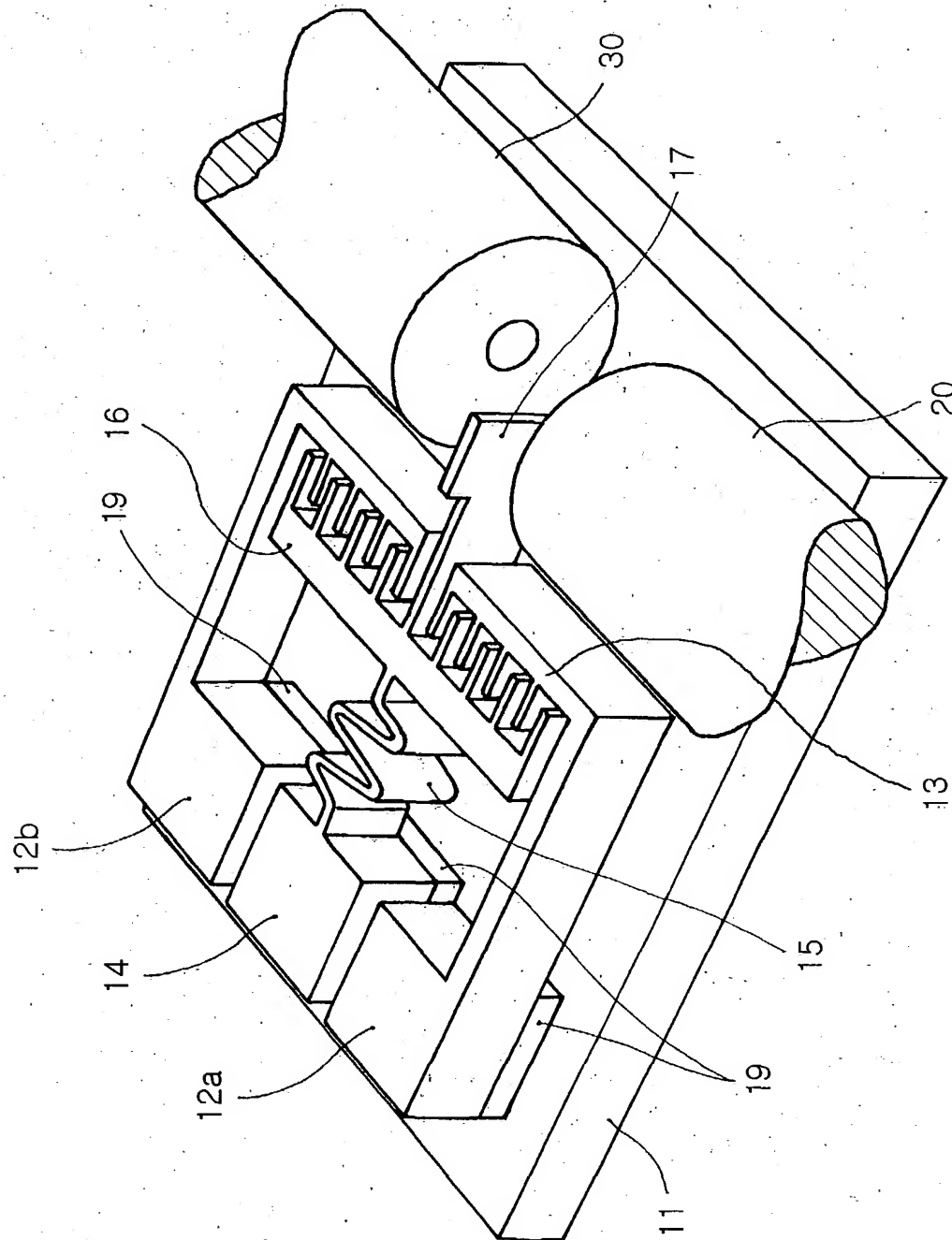


MICROELECTROMECHANICAL SYSTEMS (MEMS) VARIABLE OPTICAL ATTENUATOR

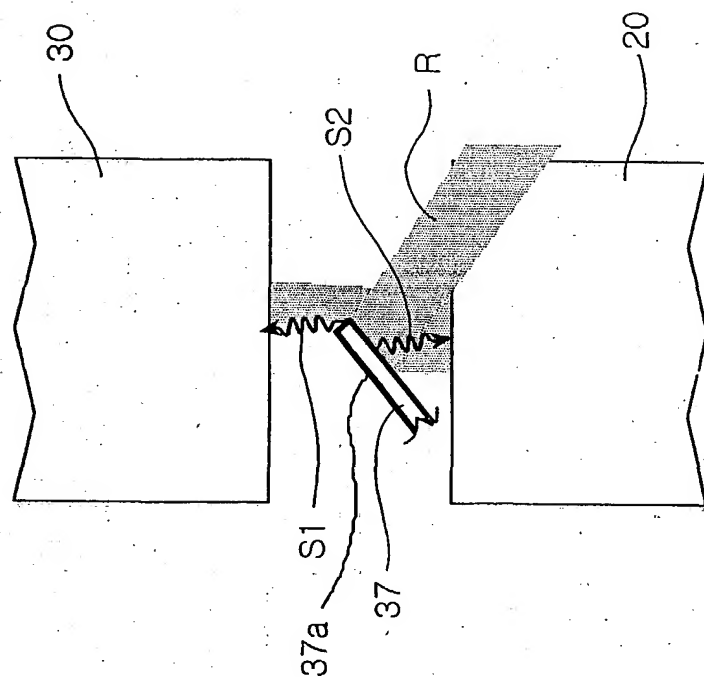
Inventor: HONG, Yoon Shik *et al.*

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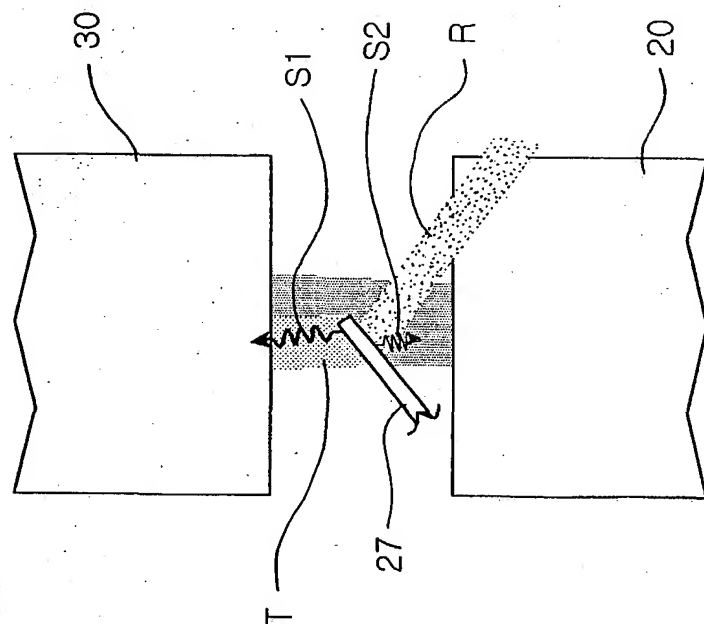


PRIOR ART



PRIOR ART

FIG. 2b



PRIOR ART

FIG. 2a

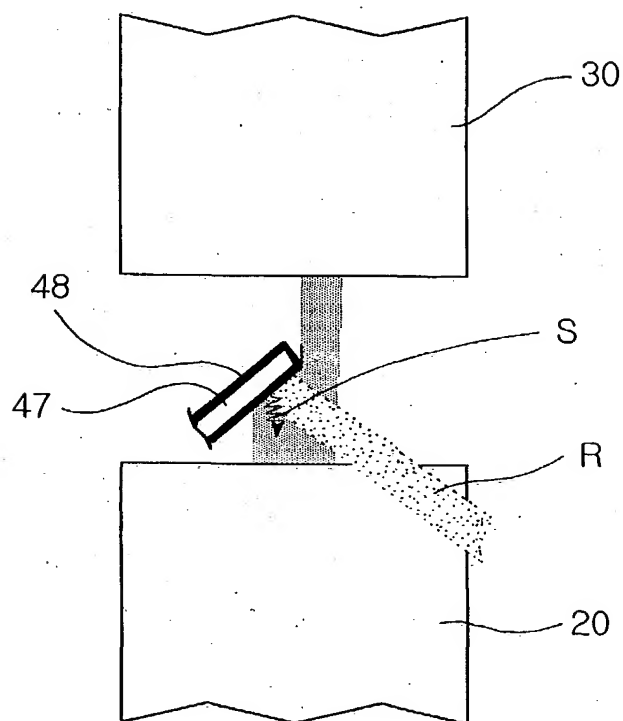


FIG. 3

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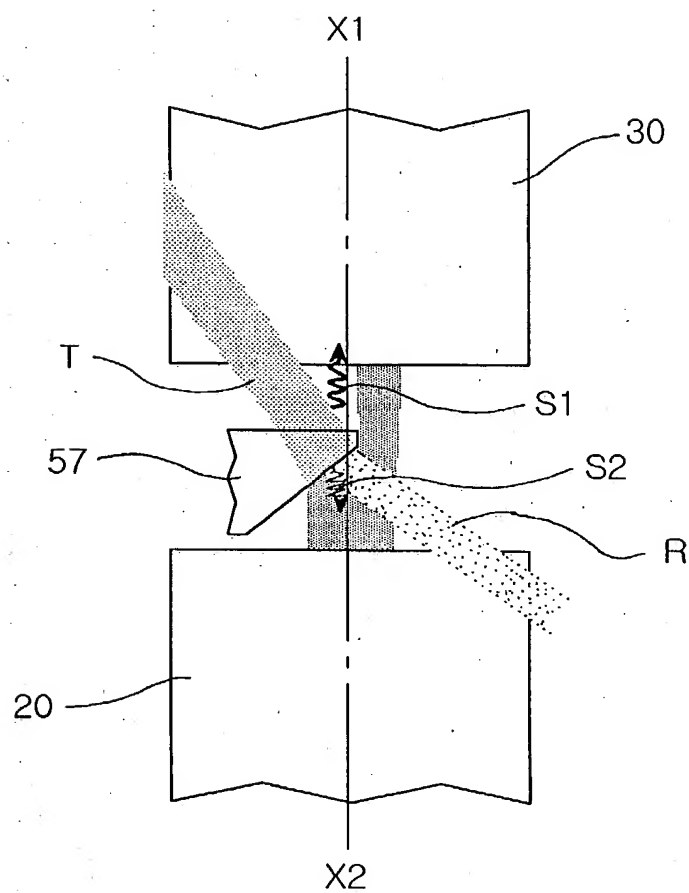


FIG. 4

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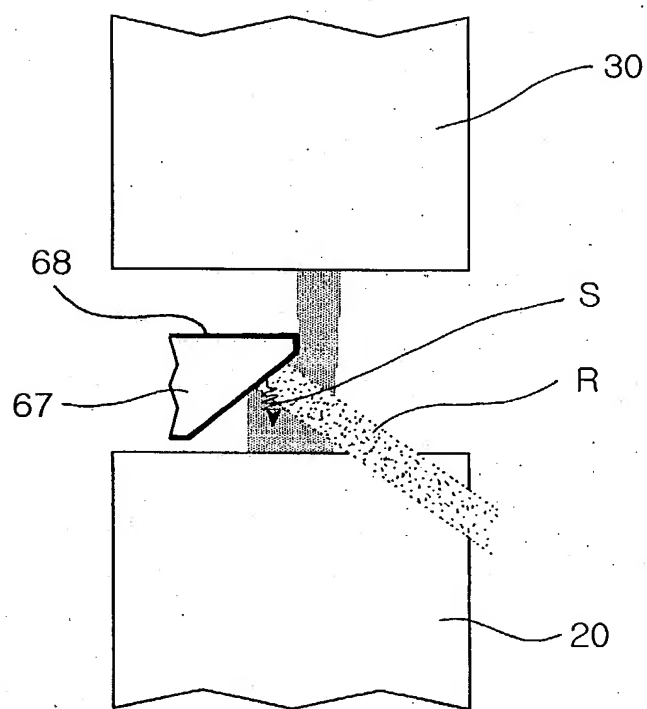


FIG. 5

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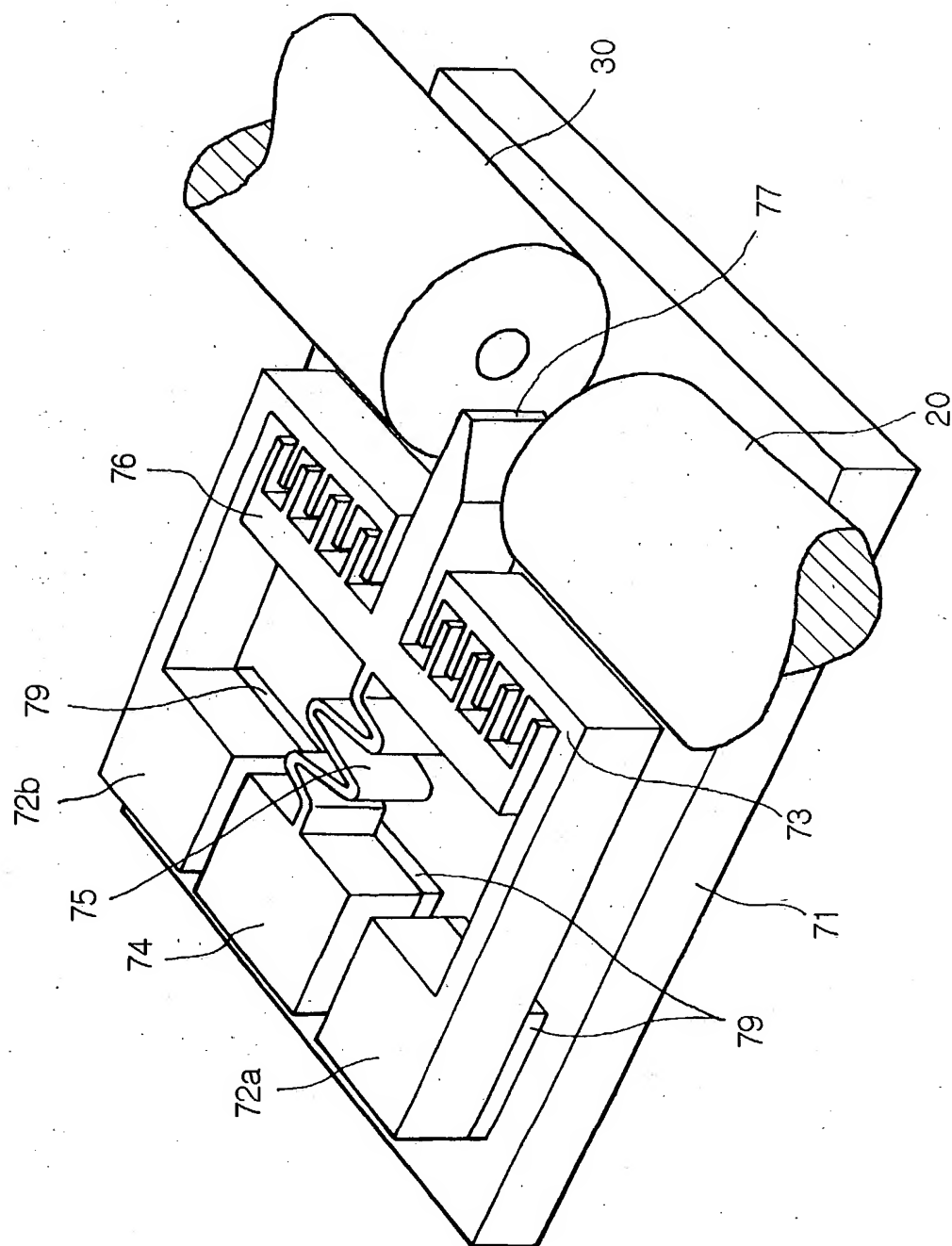


FIG. 6

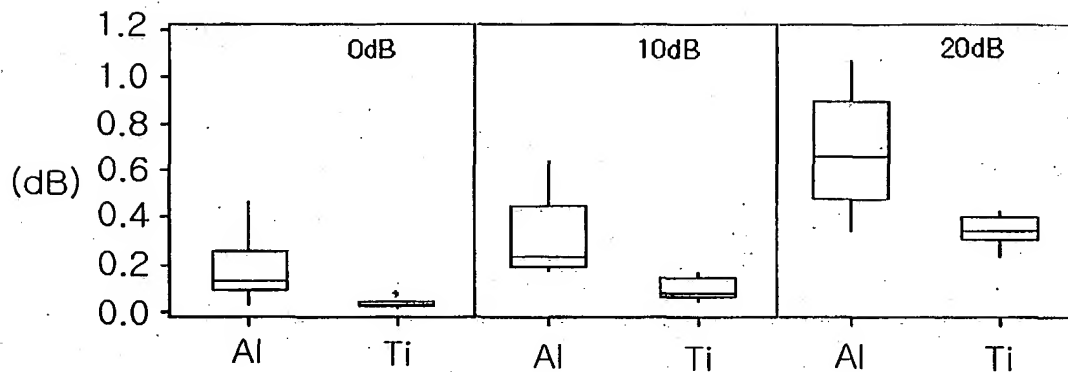


FIG. 7a

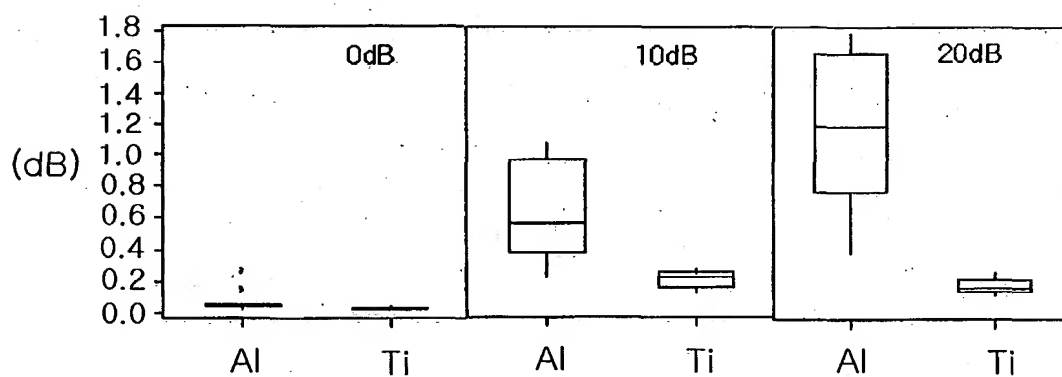


FIG. 7b